IFW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Group Art Unit: 2811
	Osamu Goto, et al.)	Examiner: Ori Nadav
Application No. 10/606,176)) I hereby certify that this document is being deposited
Filed:	June 25, 2003)	with the United States Postal Service as first class mail in an envelope addressed to: MAIL STOP AMENDMENT, Commissioner for Patents, P.O. Box
For:	SEMICONDUCTOR LIGHT EMITTING DEVICE, ITS MANUFACTURING METHOD, SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD)	1450 Alexandria, VA 22313-1450 on January 25, 2005. Torrietta Nuo7c Antonietta Musto

MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Dear Sir:

This Response is submitted in response to the Notice of Non-Compliant Amendment mailed January 13, 2005. Applicants respectfully re-submit the Amendments to the claims contained in the Response to the September 23, 2004 Office Action to comply with 37 C.F.R. § 1.121(h).

Respectfully submitted,

Dated: January 25, 2005

Manina N. Saito

Registration No. 42,121

SONNENSCHEIN NATH & ROSENTHAL LLP

P.O. Box 061080

Wacker Drive Station, Sears Tower Chicago, Illinois 60606-1080

(312) 876-8000